



Response
200309716-1

IFW

IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Inventor: Monroe et al **Confirmation No:** 9548
Serial No. 10/677,539 **Examiner:** Mai Huong C Tran
Filed: Oct 02, 2003 **Group Art Unit:** 2818
Title: MEMS Device And Method Of Forming MEMS Device

Commissioner for Patents
P O BOX 1450
Alexandria VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

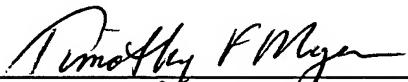
In response to your Office Action/Restriction Requirement dated September 21, 2004; Applicants affirm the election of Group II (Claims 1-27) without traverse.

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Respectfully submitted,

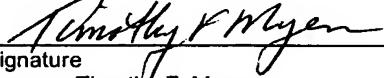
Monroe et al

By:



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Attorney For Applicants

I hereby certify that this correspondence is being deposited on the date indicated below with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313.



Signature Timothy F. Myers

Typed Name 9/29/04

Date of Signature